

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.	:	10/783057	Confirmation No.	6775
Applicant	:	Tadayuki Fujiwara et al.		
Filed	:	February 20, 2004		
TC/A.U.	:	2173		
Examiner	:	N/A		
Title	:	APPARATUS AND METHOD FOR MANAGING LIQUID CRYSTAL SUBSTRATE		
Docket No.	:	NGB-15369		
Customer No.	:	040854		

**INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir/Madam:

In accordance with Rule 56, applicant is aware of the publications listed in the enclosed copy of Patent Office Form PTO/SB/08A. These references were first cited in an Office action dated February 2, 2007 from the Japanese Patent Office in the corresponding Japanese application. A copy of the Japanese Office action, along with an English translation, is attached. A copy of each of the publications is enclosed herewith.

If there are any fees as a result of this communication, please charge same to Deposit Account 18-0160 Order No. NGB-15369.

Respectfully submitted,

RANKIN, HILL, PORTER & CLARK LLP

By \_\_\_\_\_ /David E. Spaw/  
\_\_\_\_\_  
David E. Spaw, Reg. No. 34732

4080 Erie Street  
Willoughby, Ohio 44094-7836  
(216) 566-9700